

Electronic Acknowledgement Receipt

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Application Number:	10519475
International Application Number:	
Confirmation Number:	2692
Title of Invention:	Plasma processing system and its substrate processing process, plasma enhanced chemical vapor deposition system and its film deposition process
First Named Inventor/Applicant Name:	Keisuke Kawamura
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Attorney Docket Number:	263788US2PCT
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part / .zip	Pages (if appl.)
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1		263788USAMDT.pdf	521028 <small>617cd42471b6c0947724736d5c87125b 89a2123</small>	yes	14
Multipart Description/PDF files in .zip description					
		Document Description	Start	End	
		Miscellaneous Incoming Letter	1	1	
		Extension of Time	2	2	
		Amendment After Final	3	3	
		Claims	4	5	
		Applicant Arguments/Remarks Made in an Amendment	10	14	
Warnings:					
Information:					
2	Fee Worksheet (PTO-06)	fee-info.pdf	8236 <small>3dea0675ddba1bf3c6095718216cd979 327ac93a</small>	no	2
Warnings:					
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Total Files Size (in bytes):			529264		
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